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PATENT ASSIGNMENT COVER SHEET

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Name	Execution Date
MASSACHUSETTS INSTITUTE OF TECHNOLOGY	08/15/2018

RECEIVING PARTY DATA

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PROPERTY NUMBERS Total: 1

Property Type	Number
Application Number:	15843543

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PATENT

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Invention Title: Adaptive Material Deposition for Additive Manufacturing
Inventor(s): Wojciech Matusik, Kiril Vidimce, Javier E. Ramos, Allen Soonho Park
U.S. Filing/Issue Date: 12/15/2017
Patent or Application Serial No.: 15/843, 543
Grant/Contract Number(s): IIS1409310, N66001-15-C-4030 (SPAWAR)
Foreign Applications filed/intended in (countries):
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PATENT REEL: 046993 FRAME: 0416

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